

S PATENT AND TRADEMARK OFFICE IN THE UNITED STATE

In re the application of:

TECHNOLOGY CENTER)2800

Group Art Unit: Unassigned

V. Iyer et al.

) Examiner: Unassigned

Application No.

10/039,111

Atty. Docket No. NAI1P066/

01.308.01

Filed:

For:

25

January 4, 2002

SYSTEM AND METHOD FOR

**DETERMINING REAL-TIME** 

APPLICATION VERB RESPONSE TIMES)

Date: January 30, 20

TECHNOLOGY CONTER 2800

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on January 30,

2002.

Signed:

INFORMATION DISCLOSURE STATEMENT <u>UNDER 37 CFR §§ 1.56 AND 1.97(b)</u>

Commissioner for Patents Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application feel 15 2002 does not exist, or that these references indeed constitute prior art.

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This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-1351 (Order No. NAI1P066).

Respectfully submitted,

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Form 1449 Wording

**Information Disclosure Statement By Applicant** 

TECHNOL

(Use Several Sheets if Necessary)

Atty. Docket No.

NAIIP066

Application No.:

10/039,111

Group Art Unit: Unassigned

J.S. Patent Documents

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Examiner						Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	class	Date
	Α						
	В						
	С					1	
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	E					REC	11/1
	F					TEO	FIAED
	G					SEP 1	9 2000
	Н					021-1	8 2002
	I				Te	chnology	Center 210
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	K						

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	lation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	L							
	M							
	N							
	0							
	P							

## **Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication		
	R	Bierman, Andy et al.; "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs"; http://www.ietf.org/internet-drafts/draft-ietf-rmonmib-appverbs-02.txt.		
	S	Waldbusser, Steven; "Application Performance Measurement MIB"; http://www.ietf.org/internet-drafts/draft-ietf-rmonmib-apm-mib-05.txt.		
Examiner	<del></del>	Date Considered		

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.